

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10816772
Filing Date April 1, 2004
Confirmation No.2790
InventorRamaswamy, D. V. Nirmal
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1792
Examiner Robert M. Kunemund
Attorney's Docket No.MI22-2520
Title: Methods of Depositing an Elemental Silicon-Comprising Material
Over a Substrate

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO/SB/08a

The attached Form PTO/SB/08a is submitted in compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, and your attention is directed to the references listed on the attached Form PTO/SB/08a. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: December 5, 2005

By: Jennifer J. Taylor
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